35.C14393



## #9 EOT(3) DSMQ1/s-LOGan PATENT APPLICATION 10-03-01

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)				
SHOZO HATTORI, et al.	: )	Examiner: M. Nghiem	ΞĔ		
Application No.: 09/543,331	: )	Group Art Unit: 2861	CHNOLOGY	00	72
Filed: April 5, 2000	)	•		OCT 19	ECEI
For: INK ABSORBENT, INK TANK, INK CARTRIDGE, METHOD FOR MANUFACTURING INK ABSORBENT, AND METHOD FOR MANUFACTURING INK	;		CENTER 2800	2001	VED
TANK	)	October 16, 2001			

Commissioner for Patents Washington, D.C. 20231

## PETITION UNDER 37 C.F.R. § 1.136(a)

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated April 25, 2001 for three months from July 25, 2001 to October 25, 2001.

Submitted herewith is a check for \$920.00 to cover the fee for the extension under 37 C.F.R. § 1.17. Any deficiency in or overpayment of this fee should be charged or credited to Deposit Account 06-1205. A duplicate copy of this petition is enclosed.

10/18/2001 TGEDARU1 00000076 09543331 01 FC:117 920.00 0P Applicants' undersigned attorney may be reached in our Costa Mesa,

California office at (714) 540-8700. All correspondence should continue to be directed to our below-listed address.

Respectfully submitted,

Attorney for Applicants

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